



FORM PTO-1449 U.S. Department of Commerce Patent and Trademark Office List of Documents Cited by Applicant	Application No.:	10/786,427
	Filing Date:	February 25, 2004
	First Named Inventor:	Leandra Vicci
	Group:	2832
	Examiner:	Ramon M. Barrera
Attorney Docket No.:		421/66/3

U.S. PATENT DOCUMENTS

Examiner Initial	Cite No.	Document Number	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, where relevant passages or relevant figures appear
RB	1	2004/0244470	12/09/2004	Vicci et al.	

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Examiner Initials	Cite No.	Document Number (country code, no., kind code (if known))	Publication Date	Name of Patentee or Applicant	Pages, columns, lines where relevant passages appear	T

OTHER DOCUMENTS

Examiner Initials	Cite No.	Include Author (in CAPITAL LETTERS), Title, Journal, Date, Pertinent Pages, Etc.	T
RB	2	Lee et al., "Microelectromagnets for the Control of Magnetic Nanoparticles," Applied Physics Letters, Vol. 79, No. 20, pgs. 3308-3310 (November 12, 2001).	
RB	3	Choi et al., "An On-Chip Magnetic Bead Separator Using Spiral Electromagnets with Semi-Encapsulated Permalloy," Biosensors & Bioelectronics 16, pgs. 409-416 (2001).	
RB	4	Choi et al., "A New Magnetic Bead-Based, Filterless Bio-Separator with Planar Electromagnet Surfaces for Integrated Bio-Detection Systems," Sensors and Actuators B 68, pgs. 34-39 (2000).	
RB	5	Ahn et al., "Micromachined Planar Inductors on Silicon Wafers for MEMS Applications," IEEE Transactions on Industrial Electronics, Vol. 45, No. 6, pgs. 866-876 (December 1998).	
RB	6	Drndić et al., "Micro-Electromagnets for Atom Manipulation," Applied Physics Letters, Vol. 72, No. 22, pgs. 2906-2908 (June 1, 1998).	
RB	7	Ahn et al., "A Fully Integrated Micromachined Magnetic Particle Separator," Journal of Microelectromechanical Systems, Vol. 5, No. 3, pgs. 151-158 (September 1996).	

RB	8	Ahn et al., "A Fully Integrated Planar Toroidal Inductor with a Micromachined Nickel-Iron Magnetic Bar," IEEE Transactions on Components, Packaging, and Manufacturing Technology-Part A, Vol. 17, No. 3, pgs. 463-469 (September 1994).	
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EXAMINER Baner DATE CONSIDERED 3/17/06

*Examiner Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.